

Abstract Submitted
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Mitigation of RF sheaths with insulating side walls¹ GURLEEN BAL, University of California, Los Angeles, BART VAN COMPERNOLLE, General Atomics- San Diego, MIKE MARTIN, LAM Research, WALTER GEKELMAN, PAT PRIBYL, TROY CARTER, University of California, Los Angeles — A single strap, high-power ($\sim 150\text{kW}$), RF (2.4MHz) antenna was used to study RF sheaths in a magnetized helium plasma with plasma parameters $n_e \sim 10^{18} - 10^{19} \text{ m}^{-3}$, $T_e \sim 1 - 10 \text{ eV}$ and $B_0 \sim 0.1 \text{ T}$. The experiment was conducted on the Large Plasma Device (LAPD). This presentation will draw a comparison between two experiments carried out at the LAPD with different antenna strap enclosures. The two different enclosure consisted of different materials for enclosure side walls- copper and electrically insulating, macor. Both experiments had similar plasma density, temperature, magnetic field and fast wave amplitude. In the case of the copper enclosure, formation of convective cells as a result of plasma potential rectification was observed and reported¹. In the experiments with the macor enclosure we observe a lack of plasma potential rectification as well as no evidence of convective cells. The results are reminiscent to the results obtained in ASDEX-U with the 3-strap antenna optimized to reduce image currents on the antenna limiters². ¹ M. Martin *et al*, Phys. Rev. Lett. **119**, 205002 (2017) ² V. Bobkov *et al*, Nucl. Fusion **56**, 084001 (2016)

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